

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) FIS920030350US1	Application Number Not Yet Assigned
	Applicant(s) Chen et al.	
	Filing Date Concurrently Herewith	Group Art Unit Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CK		6,251,751	06/26/2001	Chu et al.			
CK		6,375,749	04/23/2002	Boydston et al.			
CK		6,348,420	02/19/2002	Raaijmakers et al.			
CK		6,444,591	09/03/2002	Schuegraf et al.			
CK		5,397,738	03/14/95	Takagi			
CK		6,106,613	08/22/00	Sato et al.			
CK		2002/00986627	07/25/02	Pomarede et al.			
CK		2003/0036268	02/20/03	Brabant et al.			

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER	REF	"Dedicated Pre-Clean Reduces Epi's Thermal Budget", Arkadii V. Samoilov, Dale Du Bois, Paul B. Comita & David Carlson, Applied Materials Inc., Santa Clara, CA, November 1, 2000, 6 pages http://www.e-insite.net/semiconductor/index.asp?layout=articlePri...

EXAMINER <i>Christy Horacek</i>	DATE CONSIDERED <i>4/7/05</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.